POLYCRYSTALLINE SILICON RESEARCH AND **DEVELOPMENT**

UNION CARBID! APPORATION

S. lyc

TECHNOLOGY POLYCRYSTALLINE SILICON R&D	<u>REPORT DATE</u> APRIL 3C, 1986
APPROACH SILANE DECOMPOSITION IN A FLUIDIZED BED REACTOR CONTRACTOR UNION CARBIDE CORPORATION	STATUS SHORTER FLUID BED REACTOR WAS INSTALLED OPERATED LONG DURATION TEST RUNS WERE CONDUCTED USING QUARTZ & POLYSILICON LINERS PRODUCT SAMPLES WERE ANALYZED & ALSO DELIVERED TO JPL FINAL REPORT IS NEARING COMPLETION
GOALS	

FRECEDING PAGE BLANK NOT FILMED

Overview of Recent FBR Test Runs

DURATION, HOURS	SILANE CONCENTRATION	LINER
54	20%	QUARTZ
58	19 - 20 %	QUARTZ
72	15%	QUARTZ
48	30 - 60 %	POLYSILICON
	54 58 72	54 20% 58 10 - 20% 72 15%

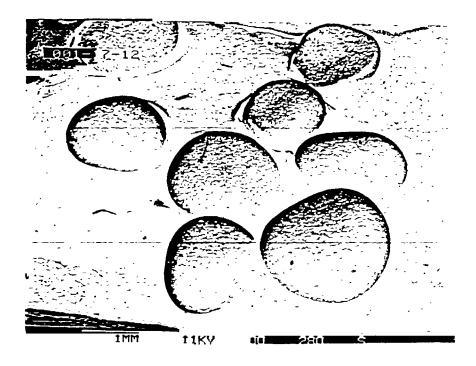
FBR Test Run J-02 Run Summary

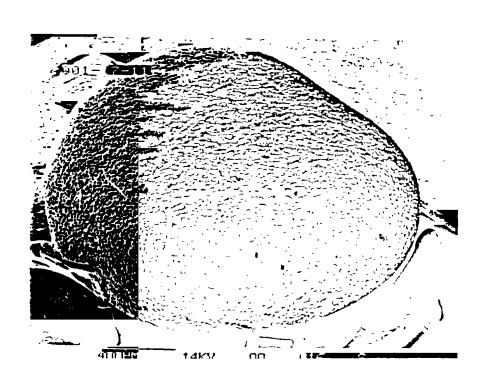
- QUARTZ LINER
- 58 HOURS DURATION
- 325 µm SEED GROWN TO 950 µm PRODUCT
- SILANE FEED RATE 2.1 KG/HR
- BED TEMPERATURE 640 700°C
- V/UMF 3.0 3.5
- COMPLETE SILANE CONVERSION
- 111 KG. PRODUCT WITHDRAWN
- POWDER 97

FBR Test Run J-02 Mass Balance

INITIAL BED WEIGHT		=	15.7 KG.
SILICON IN		=	109.3 kg.
	TOTAL	=	124.7 KG.
PRODUCT WITHDRAWN			111.2 кб.
POWDER IN FILTERS		*	11.3 кв.
	TOTAL	•	122.5 KG.
ERROR IN MASS BALANCE		*	1.8 %

SEM Pictures of Product from Run J-02





PAGE IS OF POOR QUALITY

Seed and Product Analysis for Heavy Metals Run J-02

ELEMENT	SEED, PPMA	PRODUCT, PPMA
	NAA	NAA SSMS
FE	1.6	0.69 1.0
CR	0.35	0.18 0.05
NI	0.11	0.08 <0.05

Summary of Typical FBR Product Characteristics

PARTICLE PROPERTIES

- 1000 UM DIAMETER
- 100 LB/C FT. BULK DENSITY
- SMOOTH ROUND SURFACE
- FREE FLOWING

PARTICLE MORPHOLOGY

- DENSE DEPOSITION LAYER
- LAYERED RING-LIKE GROWTH STRUCTURE
- GROWTH LAYER THICKNESS 350 µm

PARTICLE PURITY

- LOW PPB LEVELS OF BORON & PHOSPHORUS IN SINGLE CRYSTAL
- EXCELLENT POTENTIAL FOR PRODUCING SEMICONDUCTOR GRADE PURITY

Summary of FBR Research and Development

- 6" DIAMETER FBR WAS OPERATED WITH QUARTZ & POLYSILICON LINERS.
- MANY LONG DURATION TEST RUNS WERE CONDUCTED. LONGEST CONTINUOUS RUN DURATION WAS 72 HOURS.
- FEASIBILITY OF GROWING 1000 MICRON PARTICLES
 BY EFFICIENT SILANE DECOMPOSITION WAS DEMONSTRATED.
- OPERATING PARAMETERS FOR STEADY STATE CONDITIONS WERE DETERMINED.
- FEASIBILITY OF MELTING FBR PRODUCT AND GROWING A HIGH RESISITIVITY DISLOCATION-FREE SINGLE CRYSTAL WAS DEMONSTRATED.
- FURTHER WORK IS REQUIRED IN THE AREA OF HIGH-PURITY SEED PREPARATION.
- FLUID BED PROCESS IS AN ESSENTIAL ROUTE FOR MEETING FSA COST GOALS.

UCC Silane to Silicon Process Major Accomplishments

- DEVELOPMENT OF AN INTEGRATED PROCESS FOR THE PRODUCTION OF HIGH-PURITY SILANE
 - 100 MTY EPSDU
- SUCCESSFUL COMMERCIALIZATION OF UCC SILANE TECHNOLOGY
 - 1200 MTY PLANT
- DEVELOPMENT OF SILANE FLUID BED PROCESS FOR THE PRODUCTION OF LOW COST POLYSILICON
 - 6" DIA. PDU

UCC-JPL Contract 954334 Acknowledgments

- SEVERAL UCC CONTRIBUTORS
- JPL CONTRACT MANAGERS
- DOE FINANCIAL SUPPORT

PHOTOGRAPHS OF PREVIOUS

PROJECT INTEGRATION MEETINGS



























